

PATENT  
0717-0519P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: YOSHIZAWA, Takenori Conf.:  
Appl. No.: NEW Group:  
Filed: November 21, 2003 Examiner:  
For: SUBSTRATE CLEANING DEVICE AND SUBSTRATE  
PROCESSING FACILITY

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

November 21, 2003

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes:

Amendments to the Specification

Remarks